



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Satoh et al.
Appl. No. : 10/759,953
Filed : January 16, 2004
For : SEMICONDUCTOR-
PROCESSING DEVICE
PROVIDED WITH A REMOTE
PLASMA SOURCE FOR SELF-
CLEANING

Examiner : Luz L. Alejandro Mulero
Group Art Unit : 1763

CERTIFICATE OF MAILING

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

February 22, 2006

(Date)

Eli A. Loots, Reg. No. 54,715

AMENDMENT ACCOMPANYING REQUEST FOR CONTINUED EXAMINATION

Mail Stop RCE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

The present paper is submitted concurrently with a Request for Continued Examination under 37 C.F.R. §1.114 and is in response to the Final Office Action mailed November 23, 2005. Applicants hereby request entry of the following amendments and submit the following remarks.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.